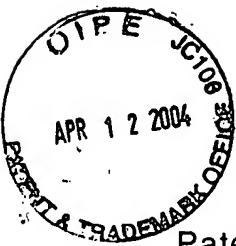


04-14-04

2812



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No.10/607,869
Filing DateJune 27, 2003
InventorshipZhongze Wang
AssigneeMicron Technology, Inc.
Group Art Unit2812
ExaminerJennifer M. Kennedy
Attorney's Docket No.MI22-2343
Title: Method of Forming Silicon-on-Insulator Comprising Integrated
Circuitry

RESPONSE TO MARCH 18, 2004 OFFICE ACTION

To: Mail Stop Non-Fee Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA EXPRESS MAIL

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
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601 West First Avenue, Suite 1300
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Responsive to the Office Action dated March 18, 2004, Applicant
amends and remarks as follows:

AMENDMENTS